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CONFIRMATION NO. 7222

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APPLICANTS
 Hiroyuki Akagawa, Tokyo, JAPAN;

**** CONTINUING DATA *******
 This application is a 371 of PCT/JP04/03617 03/18/2004

**** FOREIGN APPLICATIONS *******
 JAPAN 2003-077005 03/20/2003

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| Foreign Priority claimed 35 USC 119(a-d) conditions met | <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No | <input type="checkbox"/> Met after Allowance | STATE OR COUNTRY | SHEETS DRAWINGS | TOTAL CLAIMS | INDEPENDENT CLAIMS |
| Verified and Acknowledged | /STEWART A FRASER/ Examiner's Signature | Initials | JAPAN | 3 | 16 | 2 |

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 UNITED STATES

TITLE
 Substrate for reticle and method of manufacturing the substrate, and mask blank and method of manufacturing the mask blank

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